

OTF-1200X

Transfer to MIE

Model: OTF-1200X
Serial No: 510100791842

Tool ID: Chemical Vapor Deposition System
Booking Order:
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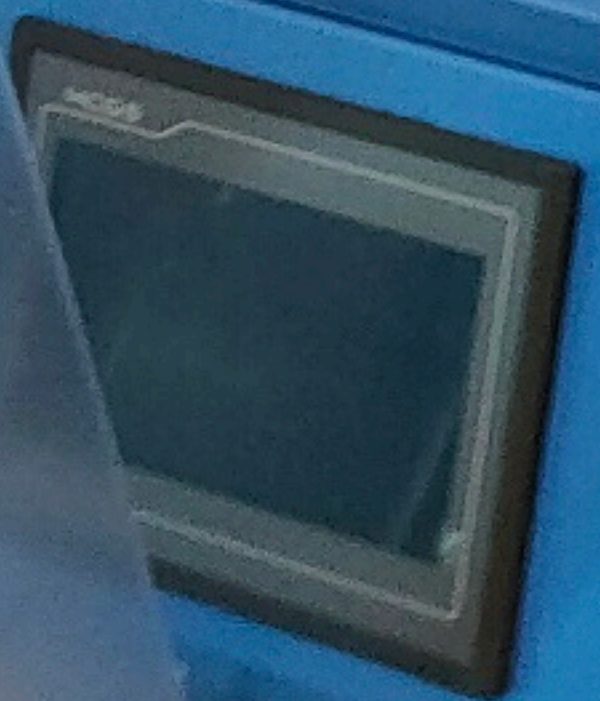
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使用时请先
放入炉塞

请注意
设备使用前，请仔
细阅读使用说明书

PATENT NO: ZL-2012-2-0184798.1

Control panel for OTF-1200X furnace. It features a digital display showing '21' and '0', a graph display, and several control buttons (red, green, black) and a knob. The panel is labeled 'MTI Corporation'.



警告
高温危险

